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PATENT
8007-1111

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants: Atsushi SAKURAI et al. Confirmation: 1454
Serial No.: 10/583,942 Art Unit: 2812
Filed: June 22, 2006 Examiner: Not assigned
For: METAL COMPOUND, MATERIAL FOR THIN FILM
FORMATION, AND PROCESS OF FORMING THIN FILM

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 7, 2007

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, included with the attached Form PTO-1449 is a search report issued November 7, 2006, in the corresponding European application, together with copies of the article and international application cited in the European search report. A copy of the cited U.S. patent is not provided in view of the USPTO waiver of the requirement to do so in applications filed after June 30, 2003.

Under the provisions of 37 C.F.R. §1.97(e), the undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this statement. Therefore, no fee is required. The Examiner is courteously requested to initial and return a copy of the accompanying Form PTO-1449 to confirm entry into the record and consideration of the listed documents.

Respectfully submitted,

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